



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 09/699,897  
Filing Date ..... October 27, 2000  
Inventor..... Mathew S. Cooper  
Assignee..... Micron Technology, Inc.  
Group Art Unit..... 1753  
Examiner ..... R. McDonald  
Attorney's Docket No. .... H0001190 (4016)  
Title: Physical Vapor Deposition Components and Methods of Formation

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10.11.03  
5/21/03  
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GROUP 1700  
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**RESPONSE TO FEBRUARY 10, 2003 OFFICE ACTION**

To: Commissioner for Patents  
PO Box 1450  
Alexandria, Virginia 22313-1450

From: James E. Lake (Tel. 509-624-4276; Fax 509-838-3424)  
Wells St. John P.S.  
601 W. First Avenue, Suite 1300  
Spokane, WA 99201-3828

**AMENDMENTS**

**Introductory Comments**

The present Response is submitted in the Revised Amendment Format and therefore qualifies for waiver of provisions 37 CFR 1.121(a), (b), (c) and (d).

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